## 209.1 - X-Ray Diffraction (powder and solid forms)

SRMs 656, 676a, 674b, 1878a and 1879a consist of high phase purity materials for use in the quantitative analysis of samples by the internal standard method. SRM 656 consists of 2 silicon nitride powders, one high in a, the other high in b. SRMs 640d, 660b, 675, and 1976a consist of materials with select crystallographic and microstructure properties used in the evaluation of diffraction equipment for the following variables; 1) d-spacing or line position, 2) line or instrument intensity, and 3) instrumental or sample contributions to happe of reflection profiles. SRM 1976a, a sintered alumina plate, is also certified with respect to lattice parameters as well as 13 relative intensity values from 22° to 155° 2q (Cu Ka). SRM 1990 is certified for lattice parameter. SRM 1994 is certified for miss orientation of the crystal axis relative to the surface normal.

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PLEASE NOTE: The tables are presented to facilitate comparisons among a family of materials to help customers select the best SRM for their needs. For specific values and uncertainties, the certificate is the only official

SRM	640d	656	660b	674b	675	676a	1878a	1879a	1976a	1990	1994	1995
Description  Unit Size	Silicon Powder Line Position + Line Shape Std for Powder Dif (7.5 g)	Silicon Nitride Powders for Quantitative Analysis (2 x 10 g)	Line Position and Line Shape, Std for Powder Diffraction (6 g)	X-Ray Powder Diffraction, Intensity Set Quant Analysis (10.00 g (powder))	Line Position, Mica (XRD) (7.5 g)	Alumina Powder for Quantitative Analysis by X-ray Diffraction (20 g)	Respirable Alpha Quartz (5 g)	Respirable Cristobalite (5 g)	Instrument Response Std for X-Ray Powder Diffraction (1 disc)	Lattice Parameter/Single, Crystal (Ruby Spheres) (3 spheres)	Standard Silicon Single Crystal Wafer for Crystalline Orientation (100-mm wafer)	Standard Sapphire Single Crystal Wafer for Crystalline Orientation (50-mm wafer)
XRD Application	Line Position Line Shape	Quantitative Analysis	Line Position Line Shape	Quantitative Analysis	Line Position - Low 20	Quantitative Analysis	Quantitative Analysis	Quantitative Analysis	Instrument Response	Quantitative Analysis	Crystalline Orientation	Crystalline Orientation

Values in parentheses are not certified but are provided as reference values or are given for information only.

## 209.1 - X-Ray Diffraction (powder and solid forms)

SRMs 656, 676a, 674b, 1878a and 1879a consist of high phase purity materials for use in the quantitative analysis of samples by the internal standard method. SRM 656 consists of 2 silicon nitride powders, one high in a, the other high in b. SRMs 640d, 660b, 675, and 1976a consist of materials with select crystallographic and microstructure properties used in the evaluation of diffraction equipment for the following variables; 1) d-spacing or line position, 2) line or instrument intensity, and 3) instrumental or sample contributions to shape of reflection profiles. SRM 1976a, a sintered alumina plate, is also certified with respect to lattice parameters as well as 13 relative intensity values from 22° to 155° 2q (Cu Ka). SRM 1990 is certified for lattice parameter. SRM 1994 is certified for miss orientation of the crystal axis relative to the surface normal.

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To SRM 1994

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2000

Calibration Standard for High-Resolution X-Ray Diffraction

(1 block)

Line Position

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